

## **AMENDMENT(S) TO THE SPECIFICATION**

**Please amend the title of the specification to:**

**OPTICAL METROLOGY METHOD ~~WHICH IS USED TO DETERMINE~~ FOR  
DETERMINING THE THREE-DIMENSIONAL TOPOGRAPHY OF A HOLE AN  
ORIFICE AND APPARATUS FOR DETERMINING THREE-DIMENSIONAL  
TOPOGRAPHIES ACCORDING TO SAID METHOD**

**Please insert a paragraph beginning at page 1, line 5:**

## **CROSS REFERENCE TO RELATED APPLICATION**

The present application is a 35 U.S.C. §371 national phase conversion of PCT/ES2004/000436 filed October 8, 2004, which claims priority of Spanish Application No. P200302355 filed October 10, 2003, incorporated by reference. The PCT International Application was published in the Spanish language.

## **BACKGROUND OF THE INVENTION**

**Please insert the following section heading at page 7, line 34:**

## **BRIEF DESCRIPTION OF DRAWINGS**

**Please insert the following section heading at page 10, line 30:**

## **DESCRIPTION OF PREFERRED EMBODIMENTS**